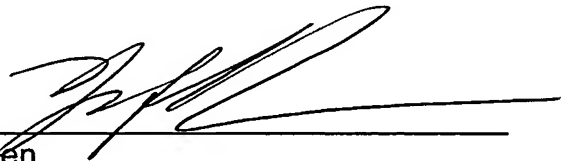


The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

Applicants certify that all references submitted with this disclosure were first cited in a communication from a foreign patent office dated October 15, 2004, which communication is enclosed, not more than three months prior to the filing of this Supplemental Information Disclosure Statement.

The Commissioner is hereby authorized to charge the sum of \$180.00 due under 37 CFR § 1.17(p) pursuant to § 1.97, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/ATTY. DKT. AMAT/7669P3/BTP.

Respectfully submitted,



Ya-Fen Chen
Registration No. 51,553
MOSER, PATTERSON & SHERIDAN, L.L.P.
3040 Post Oak Blvd. Suite 1500
Houston, TX 77056
Telephone: (713) 623-4844
Facsimile: (713) 623-4846
Attorney for Applicant(s)

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Substitute for form 1449A/PTO

**SUPPLEMENTAL
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 2 of 3

Complete if Known

Application Number	10/627,336
Filing Date	July 24, 2003
First Named Inventor	Yang et al.
Art Unit	1742
Examiner Name	Unknown
Attorney Docket Number	AMAT/7669.P3/CMP/ECP/RKK

U.S. PATENT DOCUMENTS

Examiner Initials *	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
	A24	6,518,184	02/11/2003	Chambers, et al.	
	A25	6,270,635	08/07/2001	Woo	
	A26	6,090,260	07/18/2000	Inoue, et al.	
	A27	5,162,079	11/10/1992	Brown	
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	A29	4,840,820	06/20/1989	Schultz, et al.	
	A30	4,632,851	12/30/1986	Broadbent, et al.	
	A31	4,469,564	09/04/1984	Okinaka, et al.	
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	A34	2003/0159937	08/28/2003	Gandikota, et al.	
	A35	2003/0116445	06/26/2003	Sun, et al.	
	A36	2002/0063097	05/30/2002	Fukunaga, et al.	
	A37	2002/0033340	03/21/2002	Cheung, et al.	
	A38	2001/0052465	12/20/2001	Dordi, et al.	
	A39	2004-0074761	04-22-2004	Herchen et al.	
	A40	2004-0149573	08-05-2004	Herchen	
	A41	2003-0010640	01-16-2003	Kholodenko	
	A42	2004-0074762	04-22-2004	Keigler et al.	
	A43	2004-0206628	10-21-2004	Lubomirsky et al.	
	A44	2004-0016637	01-29-2004	Yang et al.	
	A45	2004-0217005	01-14-2004	Yang et al.	
	A46	2004-0192066	01-30-2004	Lubomirsky et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				

Examiner
SignatureDate
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Substitute for form 1449B/PTO				Complete if Known	
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Application Number	10/627,336
				Filing Date	July 24, 2003
				First Named Inventor	Yang et al.
				Art Unit	1742
				Examiner Name	Unknown
Sheet	3	of	3	Attorney Docket Number	AMAT/7669.P3/CMP/ECP/RKK

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	C1	Colombo; "Wafer Back Surface Film Removal," Central R&D, SGS-THOMSON Microelectronics, Agate Italy	
	C2	Pitney, "Ney Contact Manual" October 1974	
	C3	Semitool Product Catalog (on-line) October 27, 1998	
	C4	Singer, "Copper Has Enormous Benefits When Compared to Aluminum, but its Implementation Requires Some Fundamental Changes in Process Technologies," Semiconductor International June 1998.	
	C5	Singer, "Wafer Processing," Semiconductor International June 1998.	
	C6	PCT International Search Report from International Application No. PCT/US 2004/022183, dated October 15, 2004.	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

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